

500.41316VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. KAJI, et al
Serial No.: 10/090,759
Filed: September 11, 2003
For: EMISSION SPECTROSCOPIC PROCESSING APPARATUS
AND PLASMA PROCESSING METHOD USING IT

PRELIMINARY AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 11, 2003

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment to the Title;
Amendments to the Specification and Abstract;
Amendments to the Claims;
Remarks are included following the amendments.